



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

U.S. Serial No. 10/743,608

Applicants: Nam

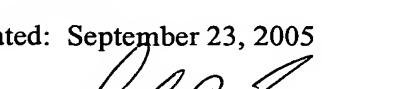
Title: Methods for Forming Capacitors and Contact Holes of Semiconductor Devices Simultaneously

Filed: December 12, 2003

TC/AU: 2891

Examiner: Steven Fulk

Docket No.: 20063/10006

-) I hereby certify that this paper (and/or fee)
 -) is being deposited with the United States
 -) Postal Service as first class mail in an
 -) envelope addressed to:
 -) Mail Stop Amendment
 -) Commissioner for Patents
 -) P.O. Box 1450
 -) Alexandria, VA 22313-1450
 -) on this date:
 -) Dated: September 23, 2005
-) 
-) Mark C. Zimmerman
-) Registration No. 44,006

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO THE OFFICE ACTION DATED MAY 23, 2005

Dear Sir:

Please enter the following amendments and consider the following remarks.

Changes to the Specification begin on page 2 of this paper.

The Status of the Claims is reflected in the listing of claims that begins on page 3 of this paper.

Changes to the Drawings begin on page 4 of this paper and include attached drawing sheet(s).

Remarks begin on page 5 of this paper.